## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Masashi Goto et al.

Title:

DIELECTRIC FILM, ITS FORMATION METHOD,

SEMICONDUCTOR DEVICE USING THE DIELECTRIC

FILM AND ITS PRODUCTION METHOD

Application No.:

TBD

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## **CERTIFICATE OF MAILING**

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**Denby** 

## PRELIMINARY AMENDMENT

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TO THE COMMISSIONER FOR PATENTS: P.O. Box 1450
Alexandria, VA 22313-1450

The Applicants request preliminary amendment of the above referenced patent application as follows.

## **AMENDMENT**

Amendments to the Specification begin on page 2 of this paper.